

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PECEIVED JAN 15 2004 TC 1700

In re Application of:

Tsunehiro NISHI et al.

Confirmation No.: 4806

Serial No.: 10/073,223

Examiner:

Sin J. Lee

Filed:

February 13, 2002

Group Art Unit:

1752

Title:

POLYMER, RESIST COMPOSITION AND PATTERNING PROCESS

## REPLY

**Mail Stop** Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed October 7, 2003, kindly amend the aboveidentified application as follows.

Amendments and additions to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 16 of this paper.

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## **CERTIFICATION OF MAILING**

I hereby certify that this correspondence is being deposited with the U.S. Postal Services as First Class Mail in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450,

on: January 7, 2004

Signature:

Name:

MILLEN, WHITE, ZELANO &